

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

**Brian H. Moeckly et al.**

**Serial No.:** 10/726,232

**Filed:** December 1, 2003

**For:** GROWTH OF IN-SITU THIN FILMS  
BY REACTIVE EVAPORATION

**Group Art Unit:** 1751

**Confirmation No.:** 3720

**Examiner:** VIJAYAKUMAR,  
KALLAMBELLA M.

**TRANSMITTAL**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

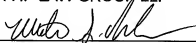
Dear Sir:

Transmitted herewith are an Amendment and Response (14 pages) in reply to the Office Action mailed October 9, 2007, and an Information Disclosure Statement (3 pages) with two copies of cited references for the above-identified application.

Respectfully submitted,  
VISTA IP LAW GROUP LLP

Dated: December 20, 2007

By:

  
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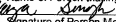
**CERTIFICATE OF TRANSMITTAL**

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being transmitted to the Commissioner for Patents, P.O. BOX 1450, Alexandria, VA 22313-1450 on the date shown below via the USPTO EFS-Web filing system.

12-20-2007  
Date of Deposit

Raiza Singh

Name of Person Mailing Paper

  
Signature of Person Mailing Paper